

# Input/Output Optics Group

## Current Members

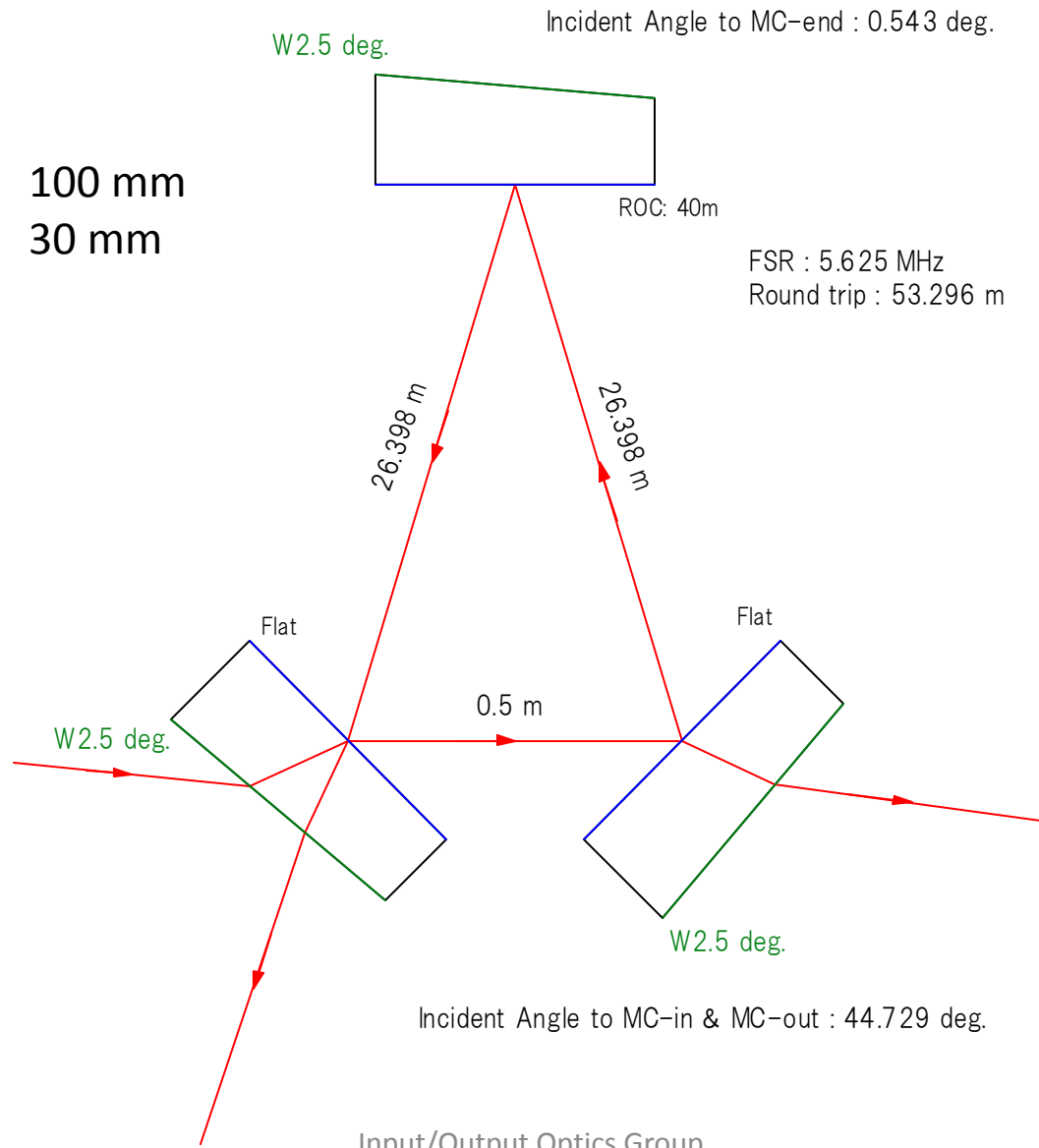
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- O. MIYAKAWA (ICRR)
- N. MIO (U-Tokyo)
- S. MORIWAKI (U-Tokyo)
- N. OHMAE (U-Tokyo)
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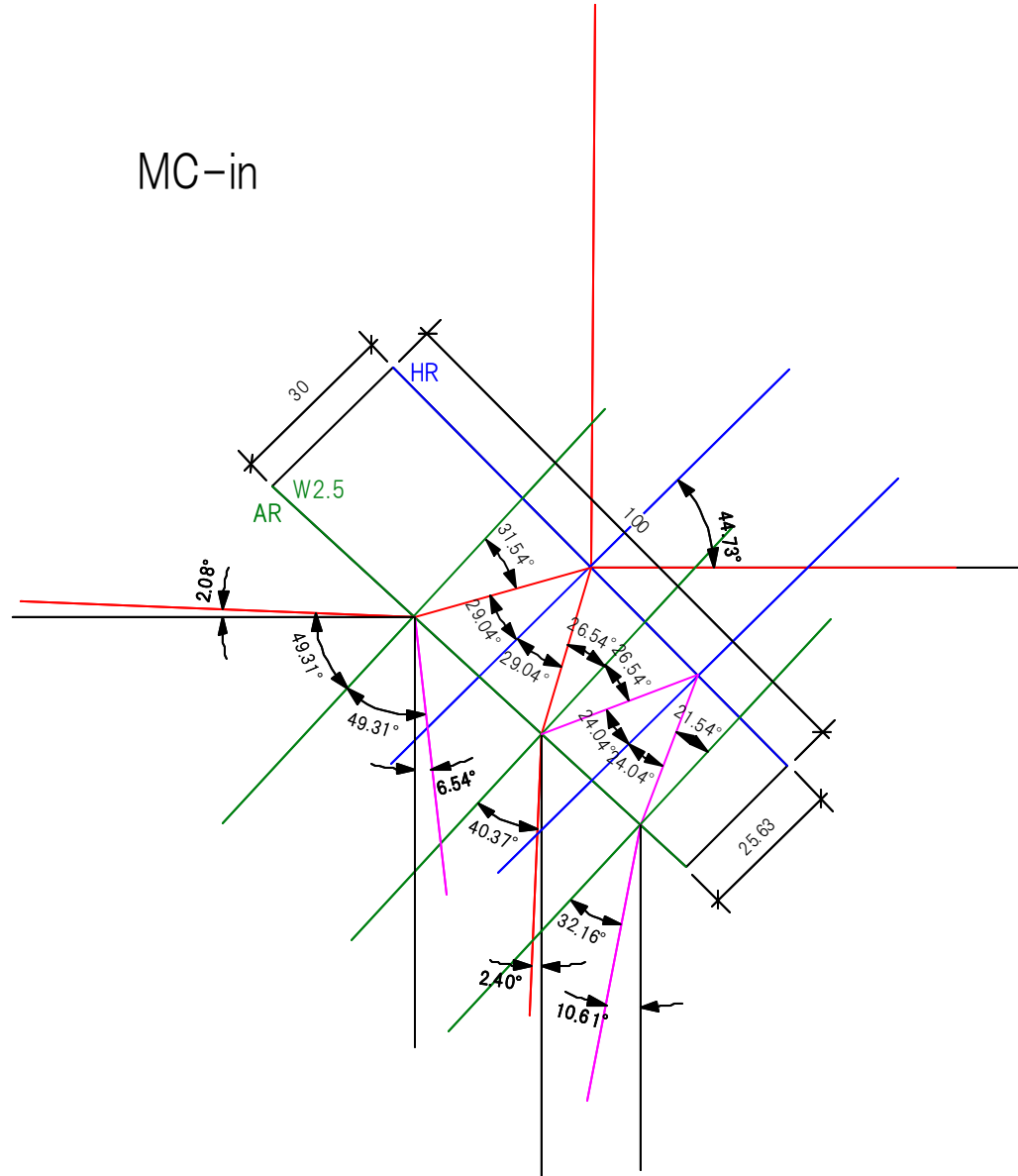
- Almost about IOO have not changed since the last f2f meeting (Feb. 4, 2011).
- Specification of MC-mirror substrates for polish was decided. And directions of input, output laser beams and stray beams war decided.

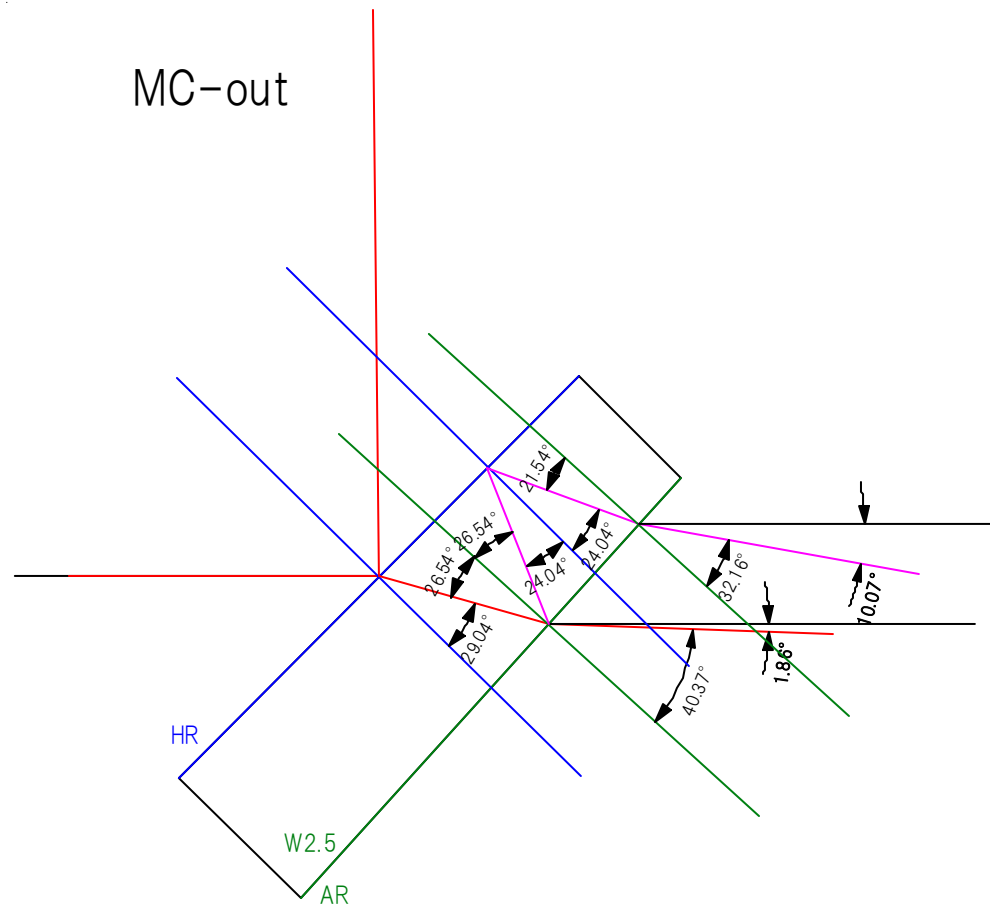
# MC Mirrors Overview

Diameter 100 mm  
Thickness 30 mm

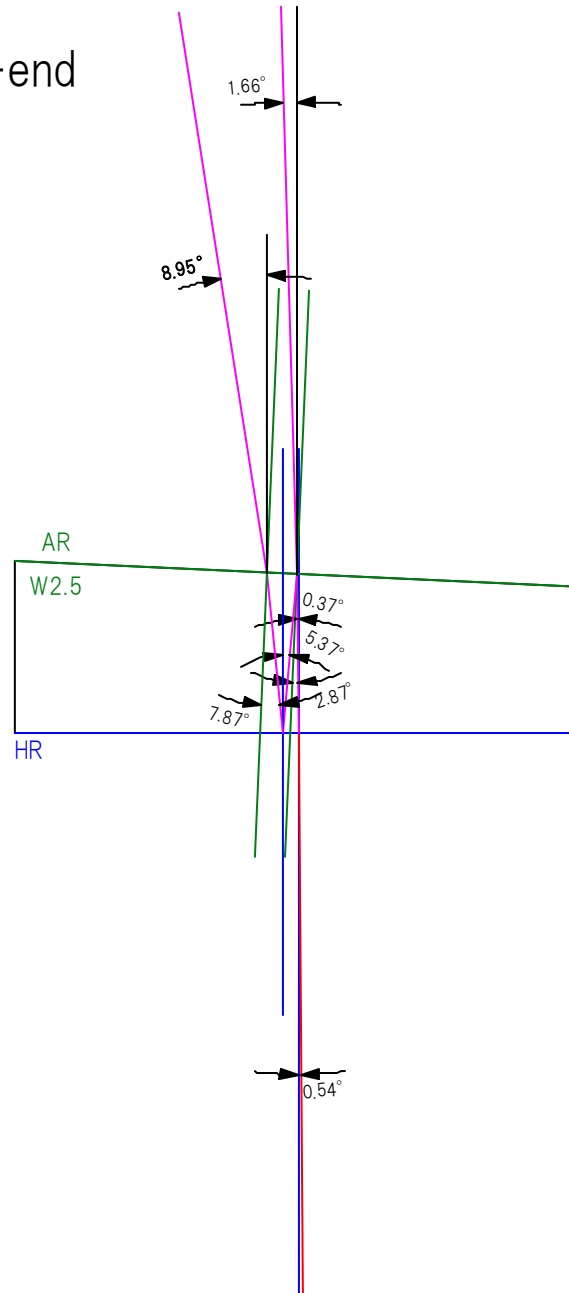


MC-in





MC-end



- We decided about substrates of mirrors for MC.
- Next we should decide about specifications of HR coatings of the mirrors.